

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3	( ((high-density or (high near2 density)) near2 plasma) and (semiconduct\$3 or silicon) and (cvd or (chemical adj vapor)) and ((silicon adj (oxide or dioxide)) or (sio2) or ("sio. sub.2")) and (hydrogen or h2 or "h. sub.2") and (oxygen or o2 or "o.sub. 2") and etch\$3 and (helium or he) and (temperature or celsius)).clm.	US-PGPUB	OR	ON	2006/04/30 16:25